

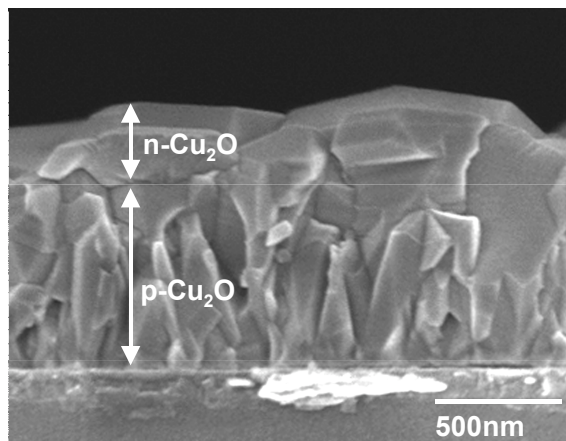
# Effect of Junction Morphology on the Performance of Polycrystalline Cu<sub>2</sub>O Homojunction Solar Cells

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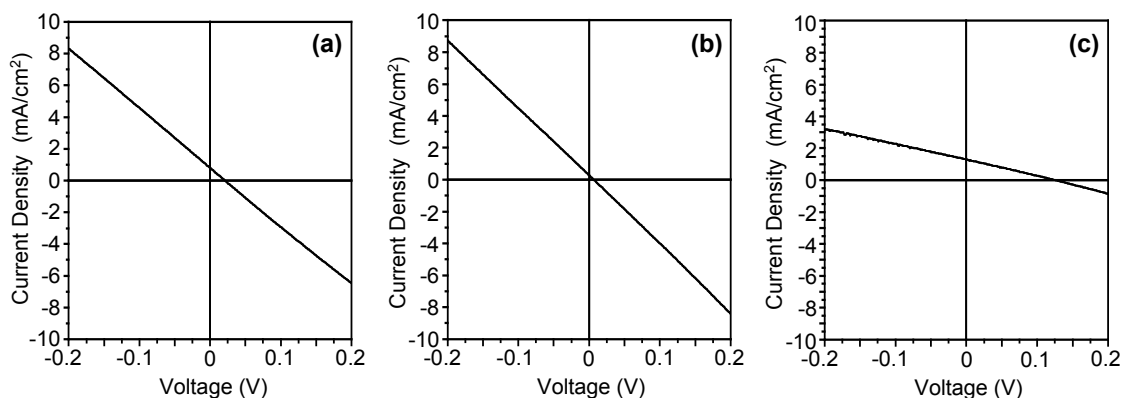
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## **SUPPORTING INFORMATION**

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**Figure S1.** The side view SEM image of p-Cu<sub>2</sub>O(II)/n-Cu<sub>2</sub>O homojunction. The p-Cu<sub>2</sub>O(II) layer is approximately 700 nm thick and the n-Cu<sub>2</sub>O layer is approximately 300 nm thick, which are identical to those forming p-Cu<sub>2</sub>O(I)/n-Cu<sub>2</sub>O homojunction shown in Figure 3a-b.



**Figure S2.** I-V curves of (a) p-Cu<sub>2</sub>O(I), (b) p-Cu<sub>2</sub>O(II), and (c) n-Cu<sub>2</sub>O layers under under 1 sun, AM 1.5 illumination. ITO substrates were used as back contacts and sputter coated AuPd dots were used as front contacts. They show a slight photoresponse indicating the presence of a leaky Schottky junction formed either at the Cu<sub>2</sub>O/ITO or at the Cu<sub>2</sub>O/AuPd interfaces, which agrees well with the imperfect Ohmic behavior observed in their dark I-V curves.